

# International Workshop on Astronomical X-Ray Optics

### Optical coherence tomography (OCT) with the use of soft X-rays as a tool for testing X-ray optics

H. Fiedorowicz, P. Wachulak, A.J. Arrikatt, A. Bartnik, K. Janulewicz

Instytut Optoelektroniki, Wojskowa Akademia Techniczna, Warszawa

G. Paulus, S. Fuchs, M. Wünsche, S. Skruszewicz, J. Nathanael, J.J. Abel, J. Reinhard, F. Wiesner, C. Rödel

Institute of Optics and Quantum Electronics, Friedrich Schiller University Jena, Germany











### Outline





1,5

1,0

0,5

0



**Optical coherence tomography (OCT)** is a well-known imaging technique that uses low-coherent light to capture two- and three-dimensional images from optical scattering media.

OCT is **performed by splitting** an illumination beam into two, namely, a reference and an object beam. The object beam is scattered from the sample, while the reference beam, superimposed with the object beam, produces an interference pattern.

Due to a **broad bandwidth** of the light (**small coherence length**), the interference occurs only if the delay between the two beams is within a coherence time, related to the coherence length.

Thus it allows to probe the internal structure of the object by changing the delay between the beams (time-domain OCT) or by recording the interference in the spectral domain (frequence-domain OCT).



#### Frequency domain OCT (FD-OCT)





The **axial resolution of OCT** is in the order of the coherence length of a light source  $I_c$  which depends on the central wavelength  $\lambda_0$  and the spectral width (FWHM) of the source  $\Delta \lambda_{\text{FWHM}}$ .

For Gaussian shaped spectrum the coherence length is defined:



$$l_c = \frac{2\ln 2}{\pi} \frac{\lambda_0^2}{\Delta \lambda_{\rm FWHM}}$$

Therefore, the **axial resolution only depends on the spectral** rather than geometrical properties of the radiation.

OCT with broadband visible and near-infrared sources typically reach axial (depth) resolutions in the **order of a few micrometers**.

The axial resolution improvement has been proposed by extention of optical coherence tomography (OCT) to the **short-wavelength coherent tomography (XCT)** using extreme ultraviolet and soft X-rays.



### Soft X-rays and extreme ultraviolet (EUV)

ISO International Standard 21348 http://www.spacewx.com/ISO\_solar\_standard.html

Soft X-rays (XUV) Extreme Ultraviolet (EUV)

 $0.1 \le \lambda < 10 \text{ nm}$  $10 \le \lambda < 121 \text{ nm}$  (He Lyman-alpha)



#### **Motivations**

- nanometer resolution (nanolithography & nanoimaging)
- nanometer penetration depth (processing of surfaces & nanoanalysis)
- elemental mapping (nanoscale)
- low inverse relative bandwith (IRB)

#### Generation

 $l_c \sim \frac{\lambda^2}{\Delta \lambda} = \lambda \, IRB$ 

- synchrotrons, FELs
- plasma sources (discharge plasmas, laser plasmas)



Realizing a classical **time-domain XCT (TD-XCT)** using a Michelson interferometer is highly demanding because of problems with optics.

In order to overcome these problems, the use of a variant of **Fourier-domain XCT** (FD-XCT) setup has been proposed.

A schematic of the proposed **FD-XCT setup**:



The **probing beam** is reflected at the layer surfaces of the sample. The beams interfere and cause a **modulated reflected spectrum** that can be measured with a grating spectrometer.

The toroidal mirror images the sample surface onto the CCD camera. The reference wave and the sample wave share the same path. Moreover, using this variety of XCT, a **beam splitter can be completely avoided**.



7

### **XCT** using synchrotron radiation



A **proof-of-principle experiment** and the first demonstration of XCT has been recently performed using **synchrotron radiation** at DESY, Hamburg (PETRA III).



S. Fuchs et al. *Scientific Reports* **6**, 20658 (2016)



### **XCT using synchrotron radiation**

**XCT demonstration** in the silicon window 30 eV – 100 eV using **synchrotron radiation** performed at DESY, Hamburg (BW3 DORIS III).



S. Fuchs et al. *Scientific Reports* **6**, 20658 (2016)



### High-order harmonic generation (HHG) source

#### fs laser system



50 fs/500 mJ/10Hz





M. Lewenstein



### HHG spectrum





### **XCT using HHG radiation source**



The XUV radiation from a HHG source is focused by a **toroidal mirror** (f = 40 cm) onto the sample's surface to a spot size of about 20 µm.

Another toroidal mirror (f = 36 cm) images this point through a **transmission grating** (1000 lines/mm) onto a CCD camera.



S. Fuchs et al. Optica 4, 903 (2017)



### **XCT using HHG radiation source**

## 3-D structured sample with two gold layers buried in silicon



### **XCT tomogram** (Lab-Based HHG source)





#### Tomogram of a 3-D structured sample with two gold layers buried in silicon



**XCT measurements** were performed on  $\approx$ 1800 lateral scanning points in an area of 960 µm × 420 µm with 15 µm step size in approximately **6.5 h**.

(a) 3D image **reconstructed** by Fourier transformation.

(b) The same in the front view. Visible are **two gold layers (Au)**, where the upper one contains the letters "XCT" as well as three additional layers closer to the surface.

Panels (c) and (d) show the 3D image of the same data set reconstructed by a three-step **phase-retrieval algorithm**.

The images in panels (e) and (f) are **additionally deconvolved** by the point spread function.

The **axial resolution** (the ability to resolve two layers) is approximately **24 nm.** 

S. Fuchs et al. Optica 4, 903 (2017)



### **XCT using HHG radiation source**

### **XCT competing with SEM and TEM**





### Lateral resolution of the XCT tomogram obtained using a HHG source.



- (a) Cross section through the sample at the depth of the upper gold layer (225 nm) in comparison with the designed structure in (c). Most features can be resolved, except for the smallest structures of the vertical bar of the letter "T."
- (b) A line out at  $y = 150 \mu m$ . The width (FWHM) of the upper part of the letter "C" is approximately 23  $\mu m$  and defines the lateral resolution.



### Laser plasma source of EUV and soft X-rays

### Schematic of a laser plasma source



#### **Source characteristics:**

- high single-pulse brightness
- short-pulse duration (ns)
- point-like shape
- easy tuning of wavelength
- low investment costs

### Main disadvantages:

- laser target operation
- target debris production









HF al. Appl. Phys. B 70 (2000) 305; Patent No.: US 6,469,310 B1



### **Compact laser plasma EUV source**

#### • schematic of the source





H.F. et al., J.Alloys&Compounds 401 (2005) 99



• spectral image at 13.5 nm



#### • EUV spectrum





~ 1.5 % CE at 13.5 nm

17



### Laser plasma soft X-ray source





# Laser plasma EUV/soft X-ray sources based on a gas puff target





















### XCT using laser plasma soft X-ray source





### XCT using laser plasma soft X-ray source

#### **Results of the preliminary XCT measurements**



P. Wachulak, A. Bartnik, H. Fiedorowicz, Optical coherence tomography (OCT) with 2 nm axial resolution using a compact laser plasma soft X-ray source *Scientific Reports* **8**, 8494 (2018)

- (a) Measured reflectivity of the Mo/Si multilayer structure in the wavelength range from 1.5 nm to 5.5 nm.
- (b) *k*-space reflectivity spectrum with a Gaussian-type window applied
- (c) Reconstruction of a **depth information** from the Mo/Si structure, experimental data (bottom, pink curve) and simulation (top, blue curve).
- (d) Visualization of **depth structure** of the sample; a comparison between theoretical and experimental data.

#### Axial spatial resolution was estimated.

The FWHM of the peak, related to the first Si-Mo interface equals to ~2 nm. Taking into account another, well defined experimental spectral peak at 30 nm depth, the FWHM is estimated to be ~2.6 nm.

The **axial spatial resolution** in XCT can be comparable to FWHM values and is of the order of **2–2.6 nm**.



Schematic of the XCT setup for 3-D imaging using a laser plasma light source



Experimental vacuum chamber



Nd:YAG laser system





Optical scheme of the XCT setup for 3-D imaging using a laser plasma light source



#### Optics and system parameters:

length of the optics d = 100.00 mm object-image distance x = 800.00 mm magnification = 4.3333 angle  $\theta$  = 11.51 deg, object distance x = 100.00 mm image distance y = 600.00 mm critical angle = 2.58 deg

#### Ellipsoidal mirrors parameters:

 $\begin{array}{l} \mathsf{A} = 400.177 \text{ mm, B} = 11.906 \text{ mm} \\ \mathsf{d}_{\mathsf{in}} = 15.759 \text{ mm, d}_{\mathsf{out}} = 20.625 \text{ mm} \\ \mathsf{NA}_{\mathsf{in}} = [0.0786, 0.0515], \\ \mathsf{NA}_{\mathsf{out}} = [0.0172, 0.0113] \end{array}$ 

#### **Detection system:**

grating width = 2.0 mm, grating period = 200.0 nm grating - CCD distance z = 58.18 mm CCD chip size = 13.0 mm, number of pixels = 1024×1024 max wavelength = 22.2 nm, dispersion = 0.043 nm/pix source size = 0.10 mm,



- optical coherence tomography (OCT) in the short-wavelength range (soft X-rays and EUV) has been proposed (XCT),
- demonstration experiments on XCT was performed using synchrotron and high-order harmonic generation (HHG) sources,
- axial resolution of 18 nm for EUV and 8 nm for soft X-rays was achieved,
- a compact laser plasma soft X-rays and EUV source based on a gas puff target was presented,
- preliminary XCT experiment with the use of the laser plasma source has been performed,
- axial resolution of about 2 nm was measured,
- design of a new XCT setup for 3-D imaging was presented.







### **Possible application of XCT – defect inspection of multilayer optics**









**Research goals:** Development of laser-driven sources of X-rays and EUV for application in science and technology

- Prof. Henryk Fiedorowicz, Przemysław Wachulak
- Dr hab. Andrzej Bartnik, Karol Janulewicz
- Dr. Roman Jarocki, Jerzy Kostecki, Mirosław Szczurek
- MSc. Antony Jose Arikkatt (PhD), Tomasz Fok (PhD), Anna Szczurek, Łukasz Węgrzyński (PhD), Inam UI Ahad, Daniel Adjei, Alfio Torrisi, Mesfin Getachew Ayele, Ismail Saber

### http://www.ztl.wat.edu.pl/zoplzm/

